

IN THE U. S. PATENT AND TRADEMARK OFFICE

In re application of

Rikizo HATAKEYAMA et al.

Conf. 6826

Application No. 10/552,709

Group 4181

Filed July 26, 2006

Examiner H. Chan

METHOD AND APPARATUS FOR PRODUCING
GAS ATOM CONTAINING FULLERENE, AND GAS ATOM
CONTAINING FULLERENE

PETITION FOR EXTENSION OF TIME

Assistant Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

January 12, 2009

Sir:

The undersigned hereby petitions for an extension of
time to respond to the Official Action of October 16, 2008 for
two months to January 16, 2009.

Please charge the extension fee of \$245.00 to our
credit card set forth in the attached Credit Card Payment
Form.

A responsive paper is filed herewith.

Respectfully submitted,

YOUNG & THOMPSON

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RJP/lk